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PATENT APPLICATION  
Docket No. 9898-314  
Client No. SS-20035-US

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Won-Jun Lee, et al.

Serial No.: 10/763,356 Examiner: Alanko, Anita Karen

Filed: January 23, 2004 Art Unit: 1765

Conformation No. 7097

For: ETCHING METHOD FOR MANUFACTURING  
SEMICONDUCTOR DEVICE

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Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

## AMENDMENT

Responsive to the Office Action, Paper No. 0106, dated January 12, 2006, please amend the application as follows.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 3 of this paper.